



PRESS RELEASE

Contact for EBARA Technologies, Inc.:

*Jim Crowley, Product Marketing Dept.
51 Main Avenue Sacramento, CA 95838
Phone: 916.923.7585
E-mail: jcrowley@ebaratech.com
www.ebaratech.com*

EBARA Technologies, Inc. announces New Pure Air Systems Abatement Products

SACRAMENTO, Calif., February 01, 2005 – Ebara Technologies Inc, Components Division, is now the exclusive North American Sales & Service representative for Pure Air Systems (www.pastdoc.com).

The Pure Air product line compliments Ebara's existing offering of point-of-use abatement systems. Pure Air's flagship product, the S.DOC, utilizes dynamic oxidation and mechanical filtration to make the safest, most efficient and cost effective system available for pyrophoric gas [Silane] treatment. The S-DOC system can be installed as a retrofit into existing competitors abatement cabinets or as a stand-alone system with only an 18" x 18" footprint. The Pure Air product line also includes the E.DOC-SC for toxic, pyrophoric and corrosive gas treatment and the E.DOC-TH for PFC and toxic gas treatment.

Pure Air Systems of Gilbert Arizona was founded in 1999 and is dedicated to minimizing industrial air pollution. Pure Air's founder, Samir Shiban, has been involved with semiconductor manufacturing since the late 70's and developed the patented Dynamic Oxidation system in 1991.

About EBARA Technologies, Inc.:

EBARA Technologies, Inc. is a U.S. based subsidiary of EBARA Corporation, a Japanese company founded in 1912, which provides a wide range of technologies including equipment, systems and services for water, air and the environment. EBARA Technologies, Inc. is a leading global innovator and worldwide supplier of vacuum technologies and advanced wafer-processing equipment for clean environments within the semiconductor industry. EBARA manufactures a full line of Dry Mechanical Pumps, Mag-lev Turbo and Hybrid Turbomolecular Drag Pumps for the semiconductor industry's toughest applications, including LPCVD, etch, EPI and Ion Implant. The company's offerings also include a complete line of Vacuum Valves and Fittings, Heaters for vacuum and exhaust lines, Point-of-Use Abatement systems, Wafer carrier and storage units, Airborne Molecular Contamination filters, Ozonized water and gas equipment. Our systems group manufactures Chemical Mechanical Polishers (CMP). EBARA Chemical Plating Systems (ECP), and Through-Mask Plating Systems (ThMP). EBARA maintains a superior sales and support network in the U.S. and worldwide. Additional information about EBARA Technologies, Inc. can be found at www.ebaratech.com.